



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kenji NISHII

Group Art Unit: 2851

Application No.: 09/628,310

Examiner: D. Esplin

Filed: July 28, 2000

Docket No.: 106827

For: EXPOSURE METHOD AND APPARATUS

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the March 3, 2003 Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please consider the following:

**Amendments to the Specification;**

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**

RECEIVED  
AUG-4 2003  
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